

FORM 1449* INFORMATION DISCLOSURE STATEMENT IN AN APPLICATION (Use several sheets if necessary)	Docket Number: 10873.827US01		Application Number: 10/014,628
	Applicant: INOUE		
	Filing Date: October 22, 2001	Group Art Unit: 3724	



U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
DR	2,020,325	11/12/1935	A. J. Myhren et al.			
DR	3,249,553	05/03/1966	S.B. Steinberg			
DR	3,744,771	07/10/1973	Deaton			
DR	4,131,658	12/26/1978	Hirata et al.			
DR	4,541,966	09/17/1985	Smith			
DR	5,609,798	03/11/1997	Liu et al.			
DR	954,451	04/12/1910	I.S. Merrell			

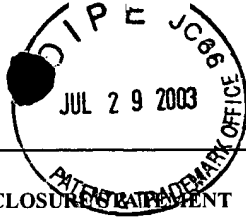
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FOREIGN PATENT DOCUMENTS							
	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
DR	465,357	05/05/1937	UK				

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		



EXAMINER <i>Dana Ross</i>	DATE CONSIDERED <i>9/10/03</i>
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form for next communication to the Applicant.	



FORM 1449*

INFORMATION DISCLOSURE STATEMENT

IN AN APPLICATION

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10873.02827US01

Application Number:

10/014,628

Applicant: Tsutomu INOUE

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2001

Group Art Unit: 3724

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
DL	US 3,439,777	April 1969	GOTHBERG			
DL	US 3,729,898	May 1973	RICHARDSON			
DL	US 3,941,355	March 1976	SIMPSON			
DL	US 4,054,622	Oct. 1977	LESTER			
DL	US 5,462,656	Oct. 1995	STANIEC			
DL	US 6,086,052	July 2000	ROWE			
DL	US 6,199,465	March 2001	HATTORI			

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FOREIGN PATENT DOCUMENTS

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						YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)



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EXAMINER

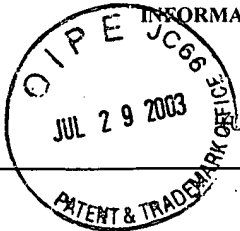
Dana Ron

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9/10/03

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CORRECTED FORM 1449* INFORMATION DISCLOSURE STATEMENT IN AN APPLICATION (Use several sheets if necessary)	Docket Number: 10873.827US01	Application Number: 10/014628
	Applicant: Tsutomu INOUE	
	Filing Date: October 22, 2001	Group Art Unit: Unknown



U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	US 992,503	May 1911	Howard			
	US 5,806,630	Sep. 1998	Bernal			
	US 5,609,798	Mar. 1997	Liu et al.			
	US 5,427,203	Jun. 1995	Anspach, Jr. et al.			
	US 4,802,555	Feb. 1989	Matsunaga			
	US 4,637,493	Jan. 1987	Ehler			
	US 4,421,798	Dec. 1983	Lin			
	US 4,335,804	Jun. 1982	Bardin et al.			
	US 4,309,456	Jan. 1982	Lock			
	US 3,939,944	Feb. 1976	Mitchell			
	US 3,756,348	Sep. 1973	Iizumi			
	US 3,618,709	Nov. 1971	Boelkins			
	US 3,491,855	Jan. 1970	Obergefell et al.			
	US 3,240,243	Jul. 1961	Golick			
	US 2,981,526	Apr. 1961	Phillip R. Grumbach			
	US 2,719,604	Mar. 1954	Allen			
	US 2,613,067	Oct. 1952	Goodyer et al.			
	US 2,438,868	Mar. 1948	V.A. Trier			
	US 2,245,601	Jun. 1941	Medsker			
	US 1,333,451	Mar. 1920	Sample			

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FOREIGN PATENT DOCUMENTS						
	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
						YES NO
	JP 9-248735	Sep. 1997	Japan			Abstract
	JP 9-159610	Jun. 1997	Japan			Abstract
	JP 7-110100	Apr. 1995	Japan			Partial
	JP 6-58491	Mar. 1994	Japan			Abstract
	JP 63-214131	Sep. 1988	Japan			Abstract
	JP 62-65147	Apr. 1987	Japan			Partial
	JP 6-193795	Jul. 1994	Japan			Abstract
	JP 6-174190	Jun. 1994	Japan			Abstract

EXAMINER <i>[Signature]</i>	DATE CONSIDERED <i>9/15/03</i>
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**FOREIGN PATENT DOCUMENTS**

	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
	JP 6-129594	May 1994	Japan			Abstract	
	JP-5-99398	Apr. 1993	Japan			Partial	
	JP-5-92596	Dec. 1993	Japan			partial	
	JP 55-2487	Jan. 1980	Japan			partial	
	JP 54-6762	Mar. 1979	Japan			Abstract	
	JP 5-45393	Jun. 1993	Japan			Partial	
	JP-53-53124	Dec. 1978	Japan			Abstract	
	JP 25-3045	Sep. 1950	Japan			Abstract	
	JP 2-122873	May 1990	Japan			Abstract	
	FR-2-670-138	Dec. 1990	France			Abstract	
	FR 1 152 856	Feb. 1958	France			Partial	
	EP-1-106-902	Dec. 1999	EPO				
	EP-0-941-769	Sep. 1992	EPO			Abstract	
	EP-0-539-055	Oct. 1992	EPO				
	EP-0-458-632	May 1991	EPO				
	DE-195-19-885	May 1995	Germany			Abstract	
	WO 93/01891	Feb. 1993	WIPO				
	WO-00/09937	Feb. 2000	WIPO				

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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